

**Ground design of the 3 GeV accelerator-complex for
synchrotron radiation facility in East-Japan**

Light **S**ource in **E**ast **J**apan

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Requirements and target performance

- 1 X-ray analysis for elements with relatively small atomic numbers, which will be important material to substitute rare-earth elements.
- 2 Low emittance beam for complete control of polarization for radiation from insertions, and ultra-high resolution X ray spectroscopy by nano-beam confinement.
- 3 Clear observation of material function and structure in nano-region.
- 4 Short pulse X ray for real-time analysis of chemical reaction and phase transition in matter.
- 5 Proper operation to derive maximum performance of the light source.
- 6 Low cost and energy saving light source facility.

On the other hand, rapid progress is obtained in accelerator technology and science

- 1 Well understanding of nonlinear dynamics for the low emittance beam
 - 2 Ultra-short period in-vacuum undulator
 - 3 Topping-up operation
 - 4 C-band linac technology for XFEL (SACLA)
-



Advanced light source facility but high reliability and stability based on recent established accelerator science and technology

• In-vacuum undulator

$\lambda_u = 15 \text{ mm}$	\Rightarrow	$\epsilon_{\text{photon}}^{1\text{st}} = 3.8 \text{ (2.6) keV}$ $\epsilon_{\text{photon}}^{7\text{st}} = 27 \text{ (18) keV}$	\Rightarrow X-ray region up to ~ 20 keV can be covered by 3 GeV class light source.
$B_0 = 0.7 \text{ T}$			
$E_e = 3 \text{ (2.5) GeV}$			

• Low emittance beam

- \Rightarrow extremely long straight section is not required any longer.
- \Rightarrow small aperture quad and sextupoles
 - \Rightarrow compact devices and ring itself.

• Recent generic technology in Japan

- \Rightarrow Progress of information and communication technologies may bring flexible control of accelerators.
- \Rightarrow Fine processing technology can produce high-performance combined function magnets



High brilliance beam based on low-energy and low-emittance ring is directly linked with low-cost, saving-energy and earth conscious.

Target of Light Source Performance

Wavelength	0.1 ~ 20 keV
Brilliance	10^{21} phs/s/mm ² /mrad ² /0.1%b.w.

Target of Machine Performance

Beam energy	~ 3 GeV
Horizontal emittance	~ 2 nmrad
Circumference	< 300 m

Some additional points to keep in mind

- Laser slicing / low alpha operation toward short-pulse production
- Topping up operation
- Seeded soft X-ray FEL driven by C-band injector

Recent medium energy class light sources

Ring	Energy (GeV)	Circumference (m)	Cell number	Beam current (mA)	Emittance (nmrad)	Brilliance @ 2-10 keV
DIAMOND	3	561.6	24	300	2.7	10^{20}
ALBA	3	268.8	16	400	4.3	10^{20}
TPS	3	518.4	24	400	1.6	10^{21}
MAX-IV	3	528	20	500	0.33	10^{21}
NSLS II	3	792	30	500	0.9	10^{21}
SPring-8	8	1436	44	100	3.4	10^{20}

It seems to be very difficult to realize 2 nmrad emittance with a circumference less than 300 m

Memorandum in designing lattice

- Proper and rational length of straight section
- Smaller cell number and many bends
- At least 10 straight section for insertions ($N_{\text{cell}} \geq 12$)
- No super long straight section, simple lattice without technical difficulty
- Introduce combined function magnets to make compact
- Employ pulse quad (or sext) beam injection

Storage ring lattice design

Lattice design strategy

Theoretical minimum emittance

$$\varepsilon_x^{\min} = \frac{1}{4\sqrt{15}} \frac{C_q \gamma^2 \theta^3}{J_x} (\text{achromat}), \quad \varepsilon_x^{\min} = \frac{1}{12\sqrt{15}} \frac{C_q \gamma^2 \theta^3}{J_x} (\text{non-achromat})$$

$$C_q = 3.83 \times 10^{-13} \text{ (mrad)}$$

θ ; bending angle (rad)

J_x ; horizontal damping partition (1 ~ 1.5)

⇒

$$18 - 27 \text{ nrad (} n_B = 20 \text{)} // 2.2 - 3.3 \text{ nrad (} n_B = 40 \text{)} // 0.65 - 0.98 \text{ nrad (} n_B = 60 \text{)}$$

n_B ; number of identical bending magnets

- Multi-bend lattice

Lattice of many dipoles in arc such as MX-IV requires dispersion suppressor at the edge of the arc.

⇒ half-bend is efficient but complicated design.

Longer arc section as lower emittance.

- Conventional Double-Bend Achromat (DBA) lattice

Many straight sections, but limited emittance for given ring.

Number of cells and number of bends

From theoretical limit of emittance, ~ 50 bends are at least required toward 2 nmrads at 3 GeV, practically.

- Consider the distance between bends in an arc

$$C \approx 2\pi\rho + N\ell_{ss} + N(n-1)S$$

ρ ; bending radius

N ; number of cells

ℓ_{ss} ; length of straight section + ~ 3 m

n ; number of bending mag in a cell

S ; length between bending mags

for example,

$$C = 300 \text{ m}$$

$$\rho = 12 \text{ m } (B = 0.83 \text{ T})$$

$$N \times n = 48$$

$$\ell_{ss} = 5 \text{ m}$$

N	n	S (m)
24	2	1.4
16	3	3.0
12	4	3.6
8	6	4.0

At least 1-set of quad and 2-set of sext have to be inserted between bends for any type of lattice.

⇒ For a 300 m ring, 24-cell DBA seems impossible, maybe 16-cell TBA too.

No trade-off and compromise between number of beam lines, the low emittance should be 1st priority.



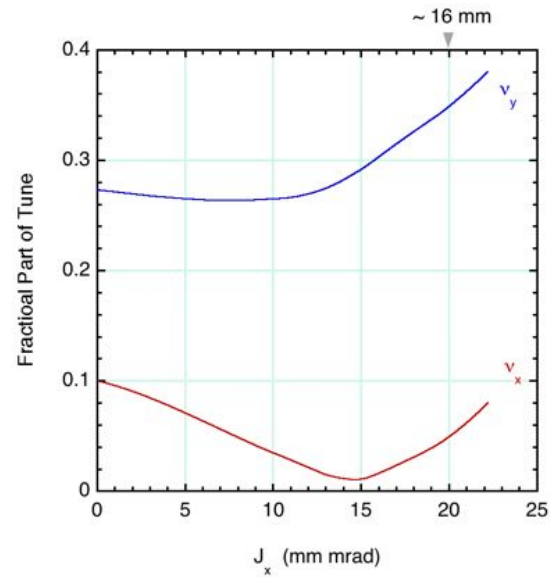
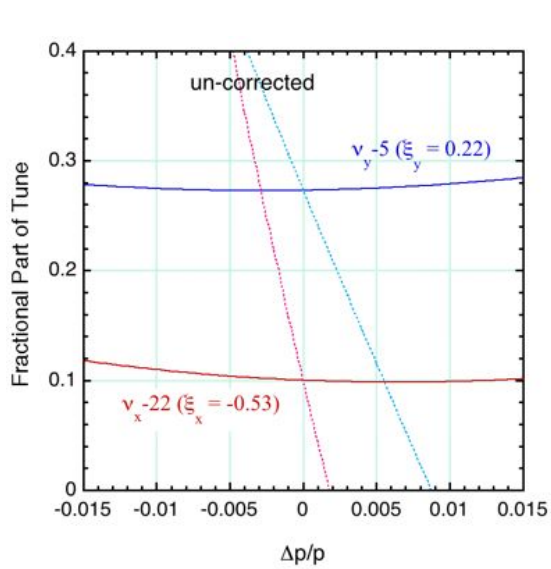
**Springboard is 12-cell of quad-bend lattice.
Non-achromat is being default toward less than 2 nmrads.**

Major machine parameters

Energy	E	2.997 GeV ($B\rho = 10$)
Circumference	C	289.2 m
Betatron tune	(ν_x, ν_y)	(22.10, 5.27)
Natural chromaticity	(ξ_x, ξ_y)	(- 56.99, - 33.58)
Natural horizontal emittance	ϵ_x	1.862 nmrad
Momentum compaction factor	α	0.00076
Damping time	$(\tau_x, \tau_y, \tau_\epsilon)$	(6.32, 8.88, 5.56) ms
Natural energy spread	σ_E/E	8.69×10^{-4}
Synchrotron energy loss	ΔE	0.652 MeV/turn
Min. and max. horizontal beta function	$(\beta_x^{\min}, \beta_x^{\max})$	(0.28, 14.71) m
Min. and max. vertical beta function	$(\beta_y^{\min}, \beta_y^{\max})$	(4.00, 26.80) m
Min. and max. dispersion function	$(\eta_x^{\min}, \eta_x^{\max})$	(0.02, 0.21) m
Length (number) of straight section	L_{ss}	5 m (12)
Lattice functions at straight section	$(\beta_x, \beta_y, \eta_x)$	(13, 4, 0.07) m

Nonlinearity correction by 6-family sextupoles

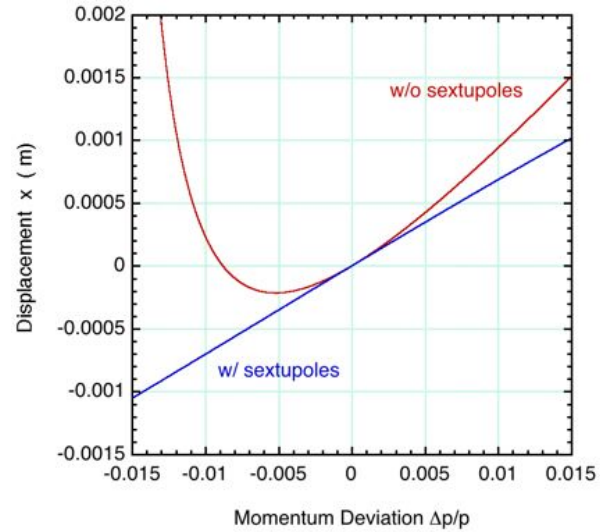
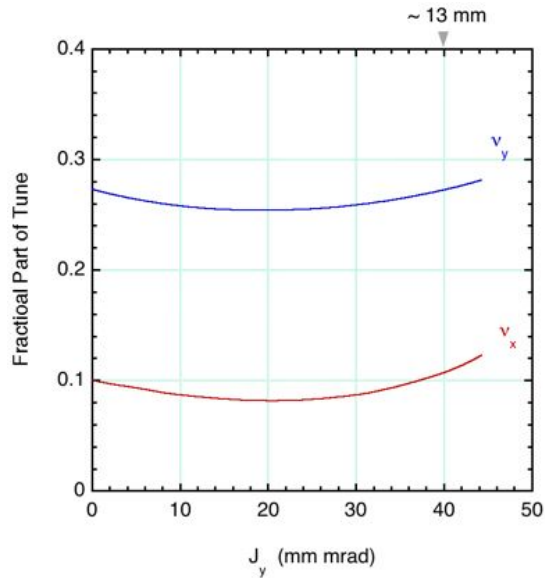
Nonlinear chromaticity



Amplitude (V) dependent tune shift

Next correction
 $\nu_x: \uparrow$ $\nu_y: \downarrow$

Amplitude (H) dependent tune shift



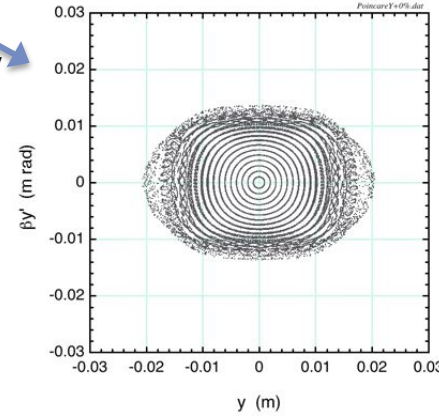
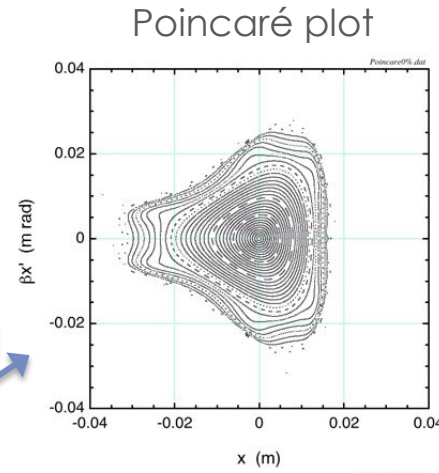
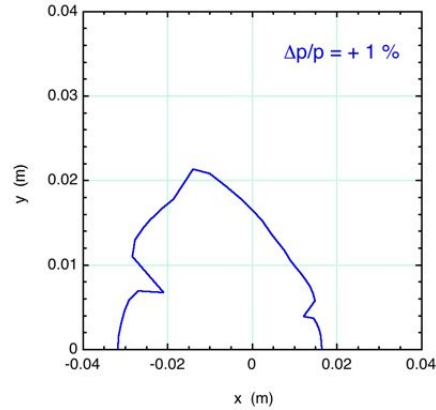
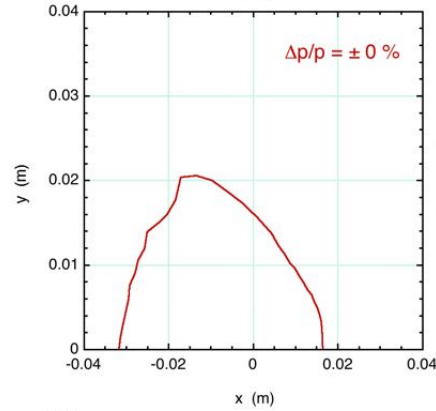
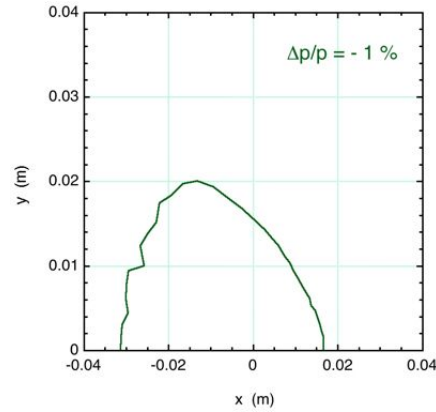
Nonlinear dispersion@ s.s.

It's original!

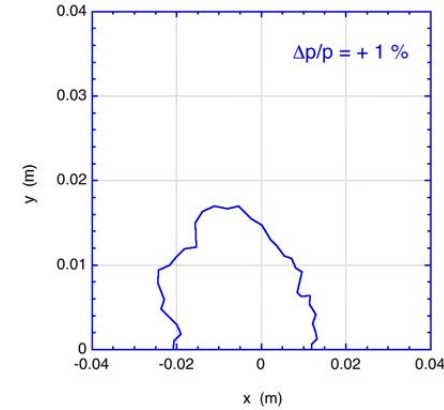
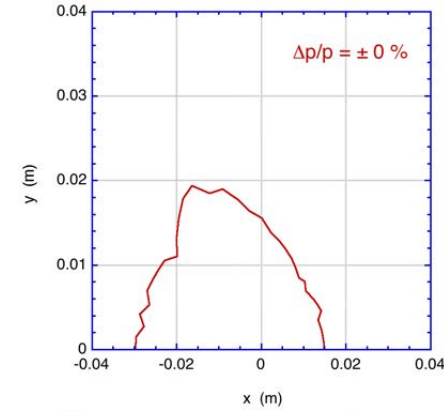
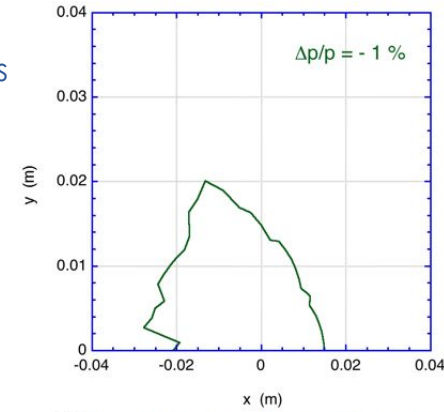
TRaCKDuCT (no RF)

Dynamic aperture

Rather stable for large amplitude particles



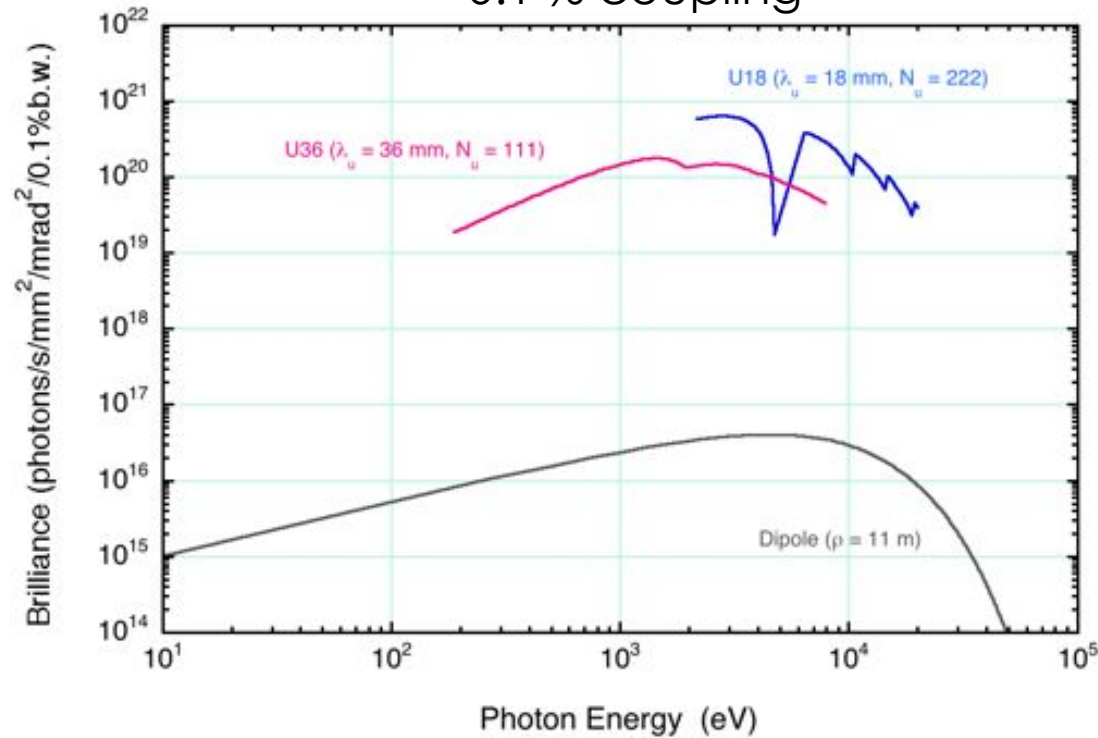
SAD ($V_{RF} = 3$ MV)



No serious defect in lattice

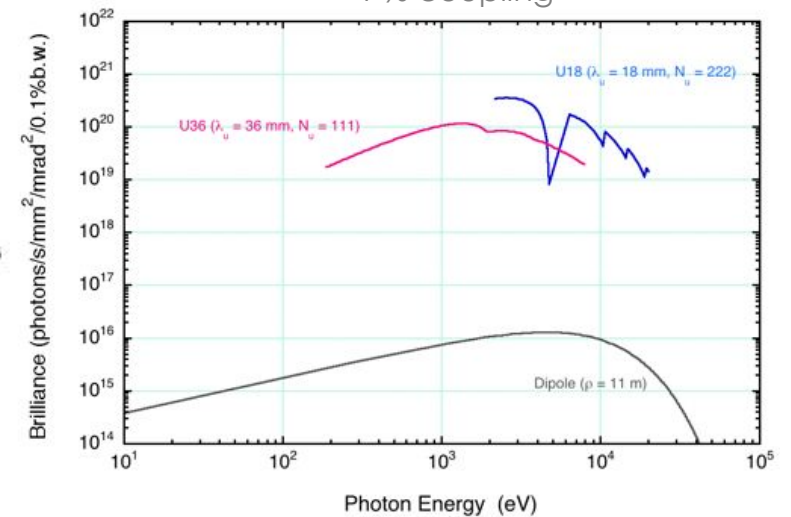
Brilliance@300mA

0.1 % coupling



Gap^{und.}_{min} = 5 mm

1 % coupling



- Still below 10²¹, but favorably comparable with recent 3 GeV class machines
- Require more brightness in lower energy region
=> optimization of undulator parameters

Injector

- Less future progress for booster synchrotron
- Employing recent advanced linac technology to secure potential ability
 - ⇒ Seeded soft X-ray free electron laser (s-SXFEL) for high quality laser (longitudinal single mode)
 - $\varepsilon_{\text{photon}} < 3 \text{ keV } (\sim 0.4 \text{ nm}), P_{\text{peak}} > 1 \text{ GW}$
- Independently developed C-band technology in SACLA has to be succeeded.

Expected characteristics of C-band injector

Beam energy	3 GeV
Normalized emittance	1 $\mu\text{m mrad}$ (0.17 nm rad @ 3GeV)
Maximum bunch charge	1 nC
Bunch length	2 ps
Energy spread	0.06%
Maximum repetition rate	50 Hz (1 ~ 10 Hz @ topping up)

- Bunch compressors have to be equipped in advance of s-SXFEL, but the total length is still $\sim 100 \text{ m}$.
- Choke structure is not necessary, conventional style of the accelerating structure to reduce cost.

Facility (tentative plan)

